## Applicant(s)/Patent Under Reexamination 10/667,368 NOGUCHI, TAKAFUMI Notice of References Cited Examiner Art Unit Page 1 of 1 Jacob Y. Choi 2875

Application/Control No.

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,025,894	02-2000	Shirasaki et al.	349/69
	В	US-2003/0048072	03-2003	Ishihara et al.	313/506
	С	US-6,327,554	12-2001	Kobori, Isamu	703/5
	D	US-2004/0263045	12-2004	Smith et al.	313/373
	Ε	US-6,556,260	04-2003	Itou et al.	3,49/69
	F	US-6,903,506	06-2005	Kita et al.	313/506
	G	US-2002/0113546	08-2002	Seo et al.	313/504
	Н	US-2002/0121860	09-2002	Seo et al.	313/506
	ı	US-6,117,529	09-2000	Leising et al.	428/209
	J	US-6,873,099	03-2005	Maeda, Tsuyoshi	313/504
	К	US-2002/0054261	05-2002	Sekiguchi, Kanetaka	349/122
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country ·	Name	Classification
	N	·				
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	Р					
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	R					
	s					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	w	
	х	

<sup>\*</sup>A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.